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Application/Control No.	Applicant(s)/Patent under Reexamination
10/665,174	SNYDER ET AL.
Examiner	Art Unit
Michael G. Mendoza	3734

SEARCHED							
Class	Subclass	Date	Examiner				
Search	Update	8/3/2006	ММ				
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)						
			DATE	EXMR		
Search Update		and the same of th	8/3/2006	ММ		